



Docket: IB-1826A

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Appl. No. : 10/656,848 Confirmation No.: 8582  
Applicant : Ka-Ngo Leung, et al.  
Title : NEGATIVE ION SOURCE WITH EXTERNAL RF ANTENNA  
Filed : 09/06/2003  
TC/A.U. : 1763  
Examiner : Dhingra, Rakesh Kumar  
Docket No. : IB-1826A  
Cust. No. : 08076

**CERTIFICATE OF MAILING OR FACSIMILE TRANSMISSION**

I hereby certify that this correspondence (along with any referred to as being attached or enclosed) is being deposited with the United States Postal Service with sufficient postage as Express mail EV635996208US in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 or facsimile transmitted to the U.S. Patent and Trademark Office on the date shown below.

Name (Type/Print) Hadiyah Muhammad

Signature

Date

11/10/2005

**Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22213-1450**

**AMENDMENT/RESPONSE**

Dear Sir:

In response to the Office Action mailed 08/10/2005, please amend the above-identified U.S. patent application as follows:

**Amendments to the Specification** are found on page 2 of this paper.

**A Listing Of Claims** begins on page 6 of this paper.

**Amendments to the Abstract** are found on page 9 and includes a replacement abstract.

**Remarks/Arguments** begin on page 10 of this paper.